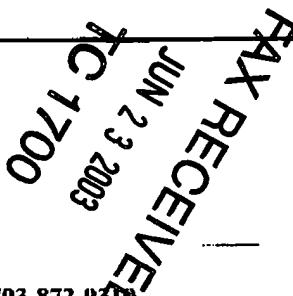
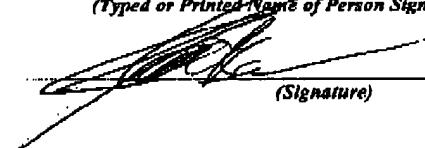


|   |                                  |                                       |                               |                                  |
|---|----------------------------------|---------------------------------------|-------------------------------|----------------------------------|
| <b>CERTIFICATE OF TRANSMISSION BY FACSIMILE (37 CFR 1.8)</b>  |                                  |                                       |                               | Docket No.<br><b>LBL-IB-1498</b> |
| Applicant(s): <b>WENBING YUN</b>  |                                  |                                       |                               |                                  |
| Serial No.<br><b>09/927,428</b>   | Filing Date<br><b>08/09/2001</b> | Examiner<br><b>DEO, DUY VU NGUYEN</b> | Group Art Unit<br><b>1765</b> |                                  |
| Invention: <b>METHOD FOR NANOMACHINING HIGH ASPECT RATIO STRUCTURES</b>   |                                  |                                       |                               |                                  |
|    |                                  |                                       |                               |                                  |
| I hereby certify that this <u>AMENDMENT (PAGES 1-30)</u><br>(Identify type of correspondence)   |                                  |                                       |                               |                                  |
| is being facsimile transmitted to the United States Patent and Trademark Office (Fax. No. <u>703-872-9316</u> )   |                                  |                                       |                               |                                  |
| on <u>20 JUNE 2003</u><br>(Date)  |                                  |                                       |                               |                                  |
| <u>JOHN P. O'BANION</u><br>(Typed or Printed Name of Person Signing Certificate)<br><br>(Signature) |                                  |                                       |                               |                                  |
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JUN 23 2003

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Inventor: WENBING YUN; ET AL.  
Serial No.: 09/927,428  
Filed: 08/09/2001  
For: METHOD FOR NANOMACHINING HIGH ASPECT RATIO  
STRUCTURES  
Group No.: 1765  
Examiner: DEO, DUY VU NGUYEN  
Docket No.: LBL-IB-1498

**Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22213-1450**

## **AMENDMENT**

#1B  
6/24/13  
m w

Dear Sir:

In response to the Office Action mailed on February 20, 2003, please amend the above-identified U.S. patent application as follows:

II

S/N 09/927,428

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